



033082M300

PATENT

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

Yasuo KOBAYASHI, et al.

Serial No.: 10/568,461

Filed : February 15, 2006

Art Unit : To Be Assigned

Examiner : To Be Assigned

For : SEMICONDUCTOR DEVICE, MANUFACTURING METHOD OF SEMICONDUCTOR
DEVICE, AND GAS FOR PLASMA CVD PROCESS

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

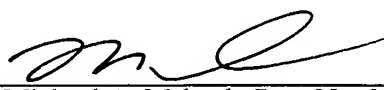
Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) and a copy of the documents cited therein. These documents were cited on pages 1 and 2 of Applicants' specification.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

This Information Disclosure Statement is being filed in advance of the receipt of a first Office Action in this application. Therefore, it is believed that no fees are due under 37 C.F.R. Section 1.97(b)(3).

Respectfully submitted,
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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	ATTY. DOCKET 033082M300	SERIAL NO. 10/568,461
	APPLICANT: Yasuo KOBAYASHI, et al.	
	FILING DATE February 15, 2006	GROUP ART UNIT To Be Assigned

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
	AH	10-144675	5/29/98	Japan			Abstract	
	AI	2000-332001	11/30/00	Japan			Abstract	
	AJ	2002-220668	8/9/02	Japan			Abstract	
	AK	09-237783	9/9/97	Japan			Abstract	
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

AQ	
AR	
AS	

EXAMINER:	DATE CONSIDERED:
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.